

2
DKing
3/13/01

Inventors: Kie Y. Ahn, Leonard Forbes and Jerome Eldridge

Title: Methods of Forming Capacitor Structures, and Capacitor Structures

Assignee: Micron Technology, Inc.

JG675 U.S. PTO
09/155673
01/05/01

INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, the Examiner's attention is directed to the references listed on the attached Form PTO-1449 and copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of these references are respectfully requested.

INVENTORS:

Date: _____

Leonard Forbes

Date: _____

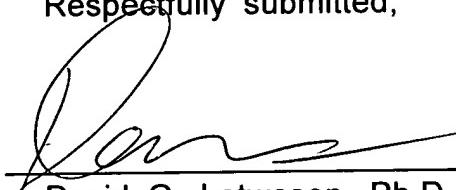
Kie Y. Ahn

Date: _____

Jerome Michael Eldridge

Date: 11/5/01 Attorney: _____

Respectfully submitted,


David G. Latwesen, Ph.D.
Reg. No. 38,533
Wells, St. John, Roberts,
Gregory & Matkin, P.S.

#2
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INVENTORS:

Date: _____

Leonard Forbes

Date: Dec. 28, 2006

Kie Y. Ahn

Kie Y. Ahn

Date: _____

Jerome Michael Eldridge

Respectfully submitted,

Date: _____ Attorney: _____

David G. Latwesen, Ph.D.
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INVENTORS:

Date: _____

Leonard Forbes

Date: _____

Kie Y. Ahn

Date: 12/28/2000

Jerome Michael Eldridge
Jerome Michael Eldridge

Respectfully submitted,

Date: _____ Attorney: _____

David G. Latwesen, Ph.D.
Reg. No. 38,533
Wells, St. John, Roberts,
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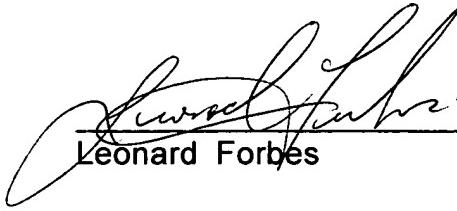
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INVENTORS:

Date: 27 Dec 2000


Leonard Forbes

Date: _____

Kie Y. Ahn

Date: _____

Jerome Michael Eldridge

Respectfully submitted,

Date: _____ Attorney: _____

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